

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants:	Alfons Eiterer et al.
International Application No.:	PCT/EP2004/012723
International Filing Date:	November 10, 2004
Priority Date Claimed:	November 10, 2003
Title:	LASER MACHINING APPARATUS AND LASER MACHINING METHOD
Attorney Docket:	BEET-17

Cincinnati, Ohio 45202

May 8, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AUTHORIZATION FOR CHARGES/CREDITS TO DEPOSIT ACCOUNT**

The Commissioner is authorized to charge any fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of the application, or credit any overpayment, to Deposit Account No. 23-3000.

Respectfully submitted,

/David H. Brinkman/  
David H. Brinkman  
Reg. No. 40,532

Wood, Herron & Evans, L.L.P.  
2700 Carew Tower  
441 Vine Street  
Cincinnati, OH 45202-2917

Voice: (513) 241-2324  
Facsimile: (513) 241-6234